

CERN MPT workshop  
DRD1-WG6  
20/06/2024

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Serge Ferry  
Rui De Oliveira

- Vacuum deposition machine
- DLC deposition status
- uRgroove detectors



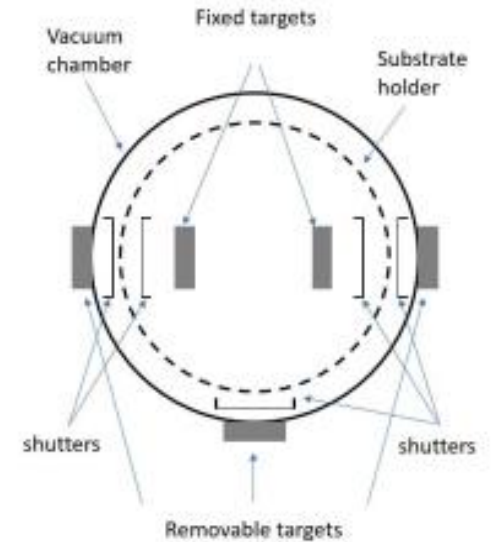
# Machine configuration reminder



The graphite target



The three external cathodes



Drum:  
55cm diameter  
70cm height  
1.7m circumference

- Test samples to tune the recipes

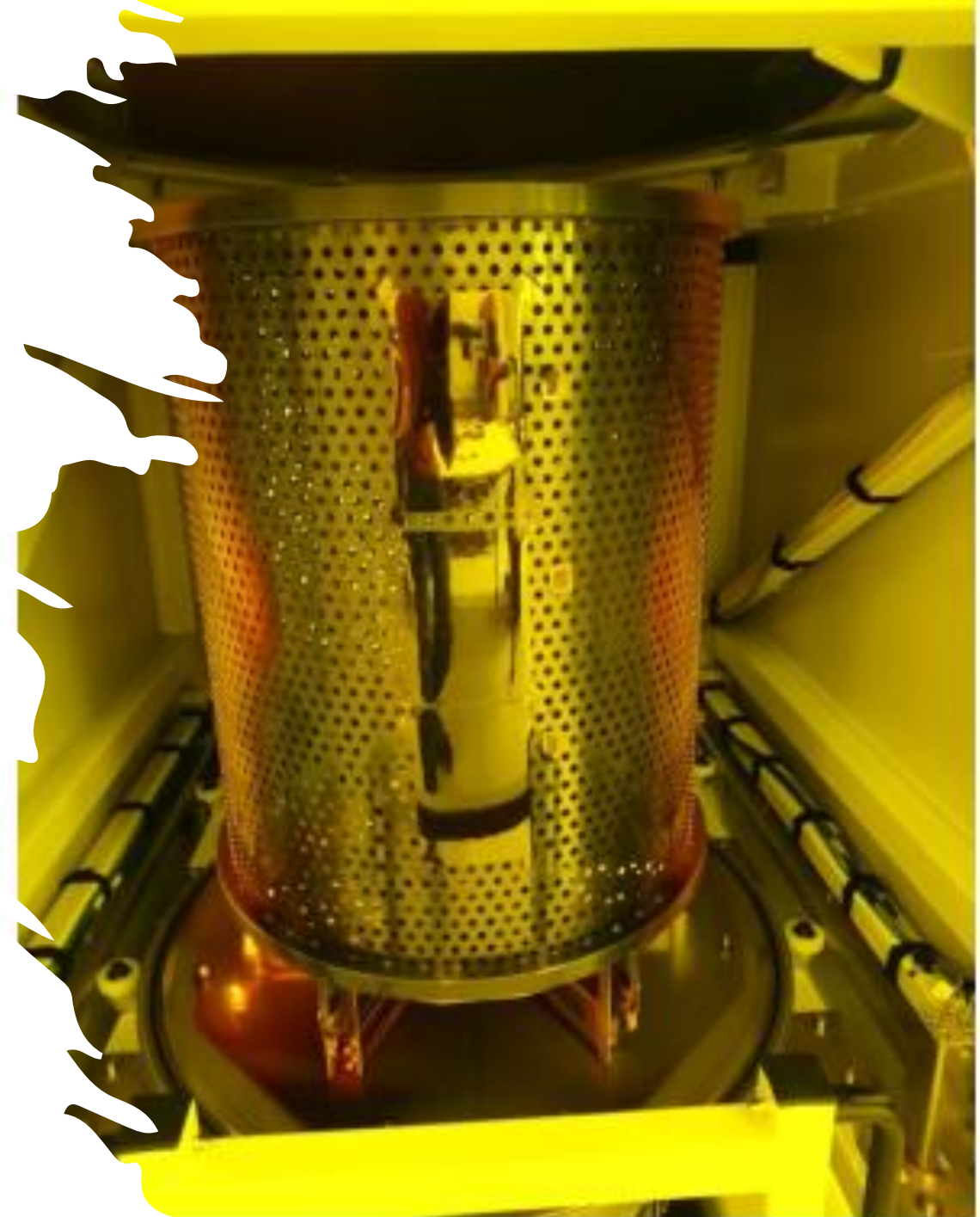
- Vertical samples, 60 x 10 cm<sup>2</sup>
- APICAL NP polyimide 50um thick
- Sample preparation → drying 220 deg for 4 days

- Main steps during a RUN

- 1/ Ar based plasma sample cleaning
- 2/ Ar based plasma + graphite target cleaning
- 3/ Ar/C<sub>2</sub>H<sub>2</sub> plasma + graphite target cleaning
- 4/ Ar/C<sub>2</sub>H<sub>2</sub> plasma + final sputtering process

- Post RUN

- Direct resistivity measurements
- Baking samples to stabilize the value
- Monitoring of the resistivity during the following days (stability check)

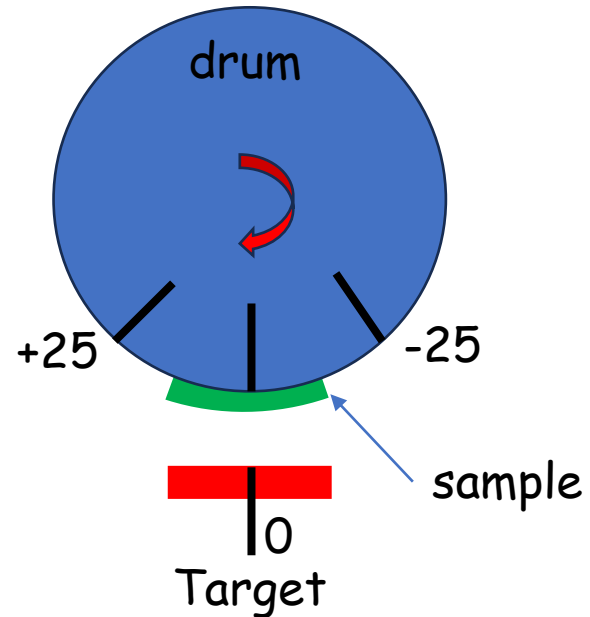


# 3 deposition methods

## Oscillation/step by step/rotation

### Oscillation:

Adjustable angle : 0 to +/-90deg  
Adjustable speed  
Adjustable time



### Step by step:

0 to 360 deg  
Adjustable steps  
Adjustable static time

Ex: -25 to +25 in 10 steps of 90s

### Rotation:

Constantly rotating  
Adjustable drum speed  
Adjustable time

### 1 - Sample cleaning:

Shutter closed  
Target power: off  
RF power : 500W  
t = 600 sec  
Ar = 150ml/min

→ RF power stopped for 15s to evacuate species in the chamber

### 2 - Target pre-sputtering cleaning:

Shutter closed  
Target power: 500W  
RF power : 300W  
t = 300 sec  
Ar = 150ml/min

### 3- Pre-sputtering @ nominal parameters

Shutter closed  
Target power : 1200W  
RF power : 500W  
t = 60 sec  
Ar = 200ml/min  
C2H2= 2ml/min

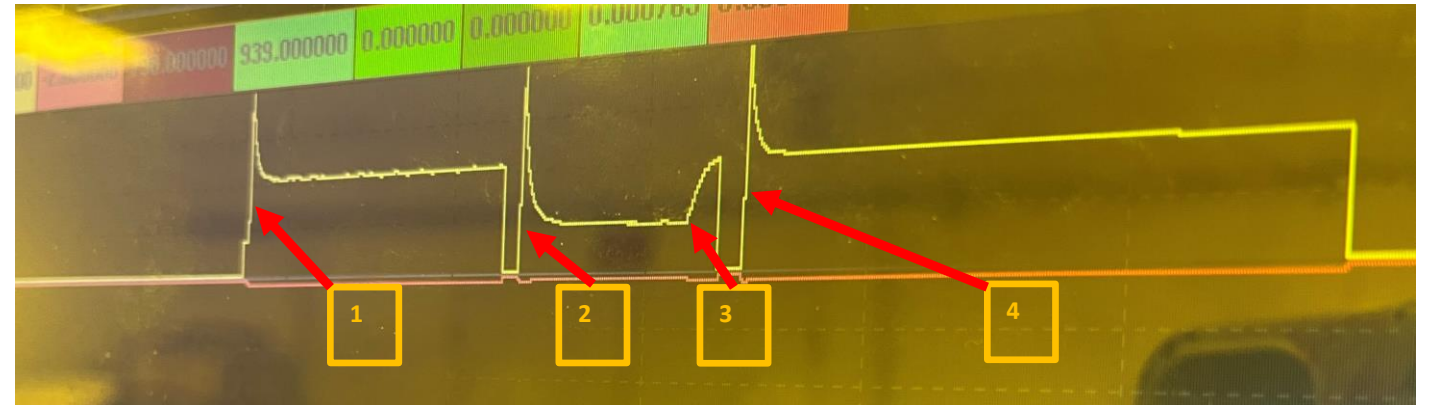
→RF and Target power stopped for 15s to evacuate species in the chamber

→ open the shutters

### 4 - DLC deposition :

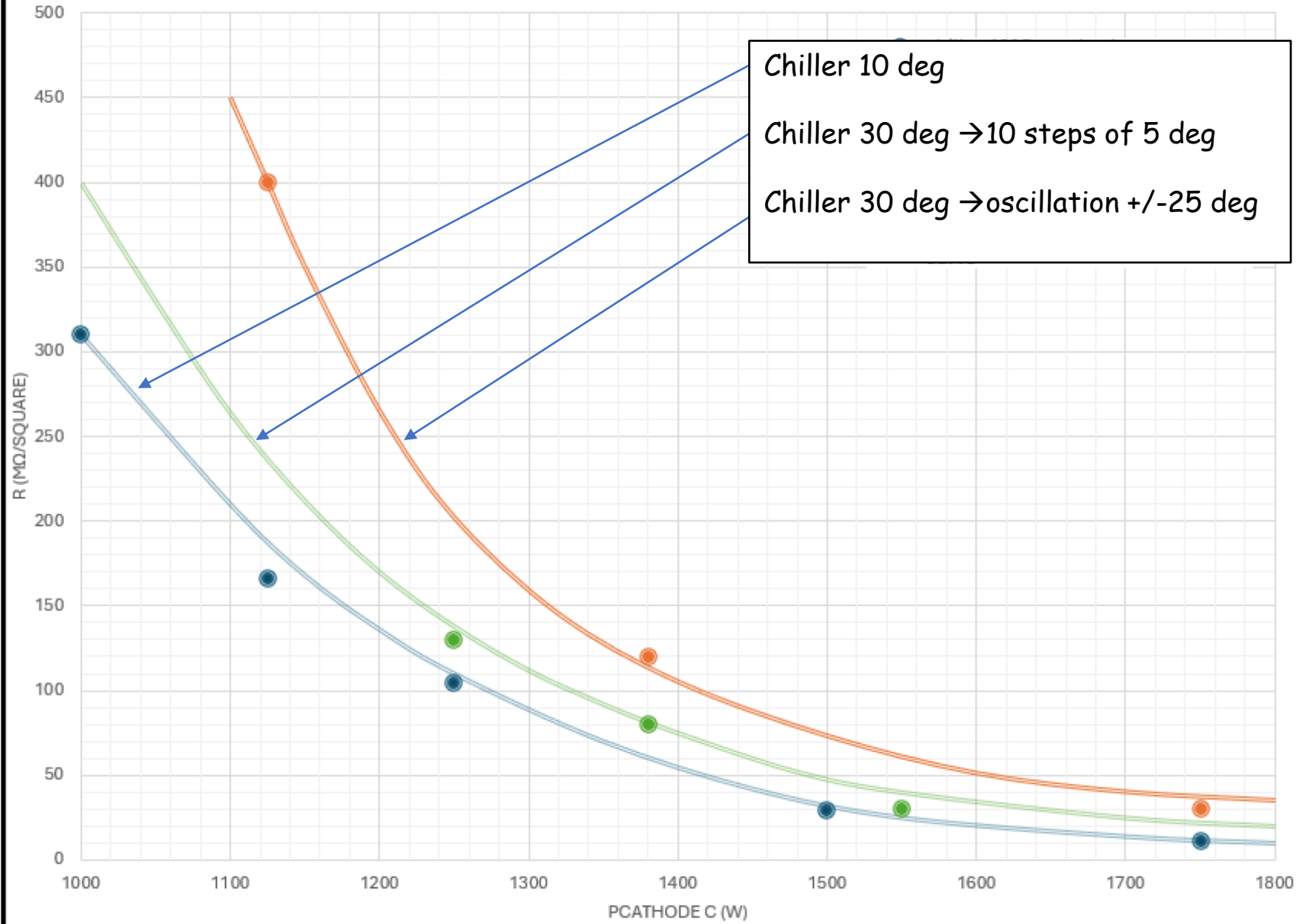
Target power : 1200 W  
RF power : 500 W  
t = 900 sec  
Ar = 200ml/min  
C2H2= 2ml/min

Chamber pressure :  $5.10^{-3}$  m.bar.  
Drum speed 1 turn/min  
Oscillation : +25deg to -25deg  
Chamber pressure regulation 52% of the maximum



RF power profil during DLC coating

### Resistivity = f(Power of C cathode)



Chiller 10 deg  
Chiller 30 deg → 10 steps of 5 deg  
Chiller 30 deg → oscillation +/- 25 deg

P = 5.10<sup>-3</sup>mbar  
Ar = 200ml/l  
C<sub>2</sub>H<sub>2</sub> = 2ml/l  
RF power = 500W  
t = 900s deposition time

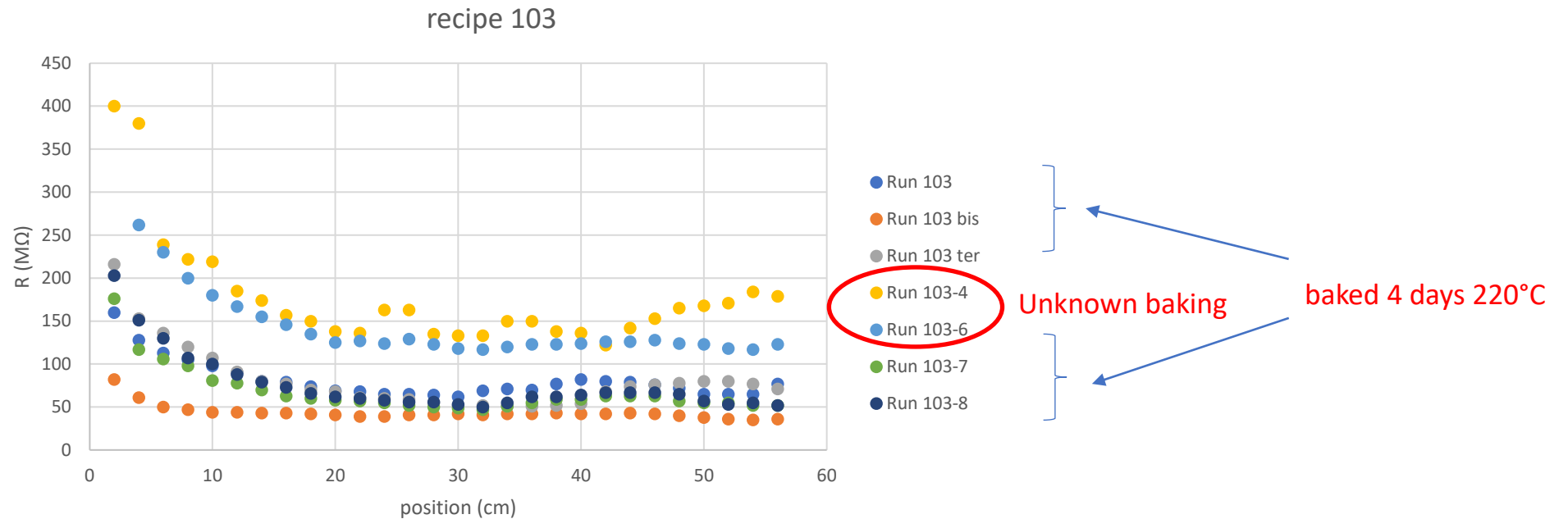
These are typical curves:



Test samples should be produced before each production to fine tune.

A large range of resistive values can be reached:  
-10K to 10G

# Repeatability



The repeatability is obviously much better if no water is present during deposition . We are now drying the foils 4 days at 220°C , this treatment is probably excessive .

We got problems to apply this baking cycle to APICAL with copper on one side. Tests are going on to reduce temperature and optimize the time to reach the optimum drying.

From the document : Moisture pick-up and minimum drying conditions from ESA, I have extracted the following info :

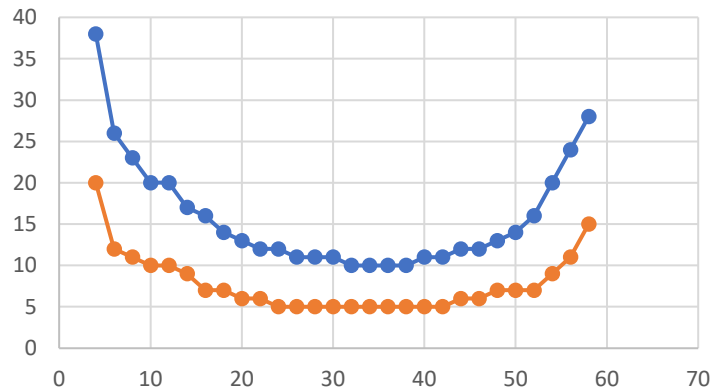
- At 120 deg the PI should be sufficiently dry after 5 days .
- 120 deg/12hours correspond to 105 deg/48 hours
- rule : the time should be multiplied by 2 each time the temperature is reduced by 7.5 deg.

# Post baking

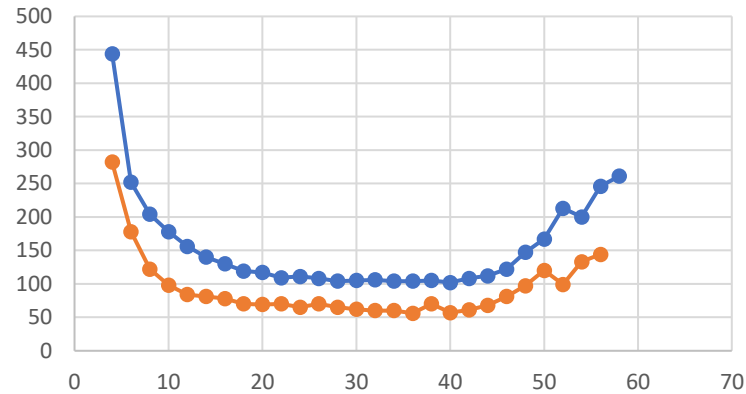
Resistivities are divided by 2 after baking 2h 220deg.

Except thinner layer with high values (????).

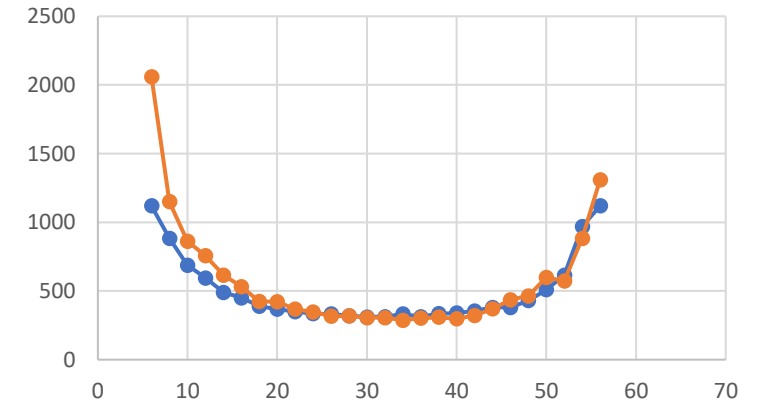
P cathode = 1750W



P cathode = 1250W



P cathode = 1000W

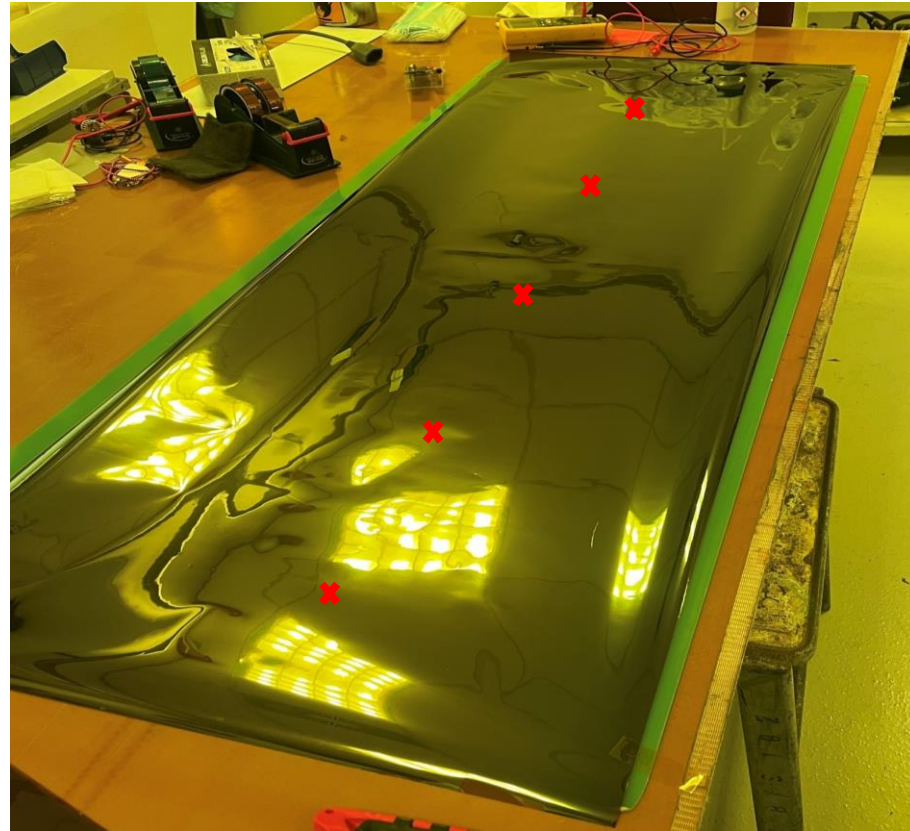


Blue before baking  
Orange after baking



# Large foils :

as expected, good homogeneity along the 1.7m axis



298 M $\Omega$

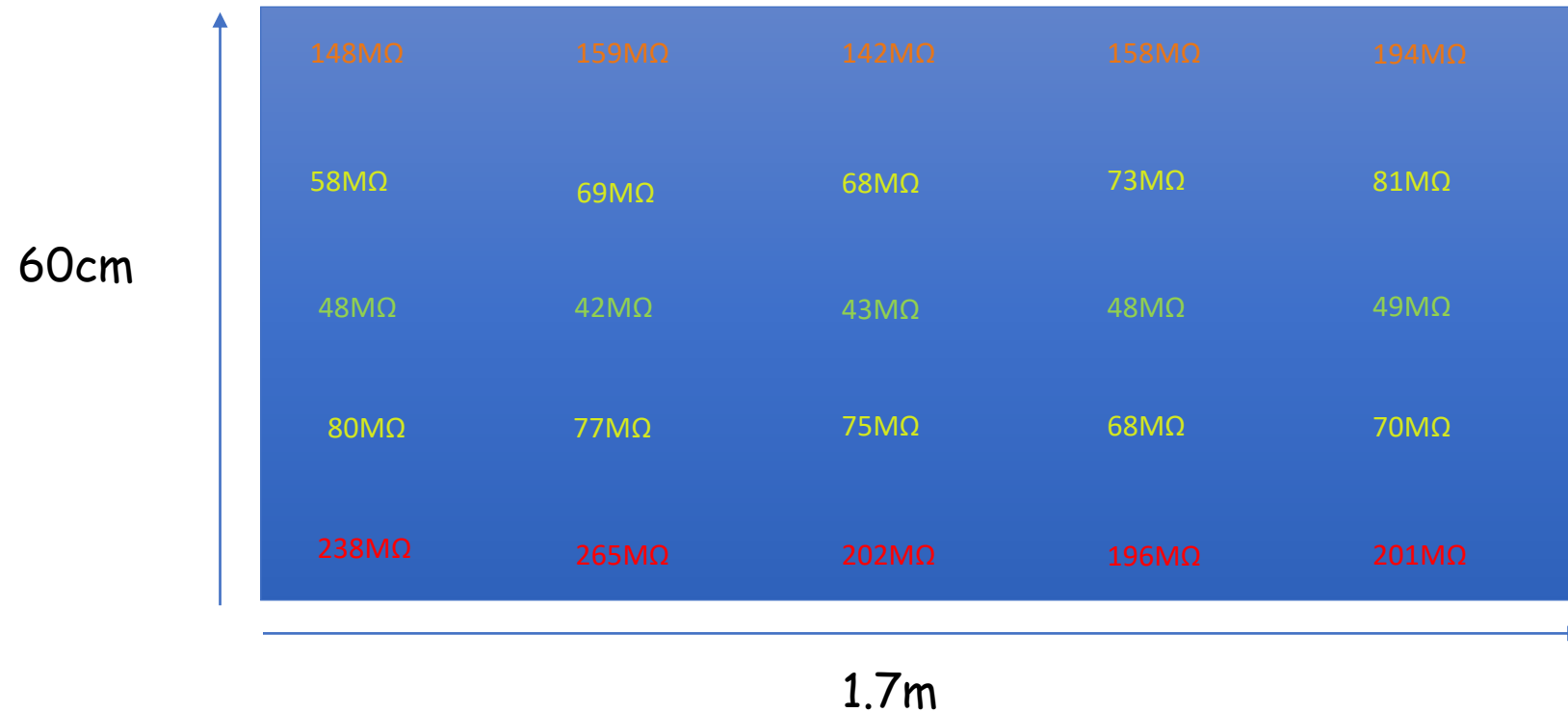
304 M $\Omega$

324 M $\Omega$

330 M $\Omega$

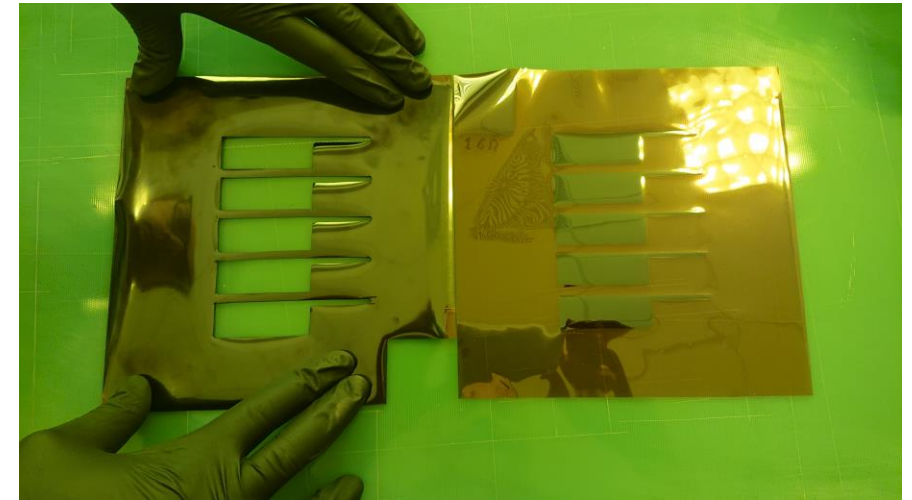
304 M $\Omega$

Second large foil - 1700mmx610mm - DLC  $\approx 60 \text{ M}\Omega$  +/-30% over 45cm



# • Situation with DLC coatings

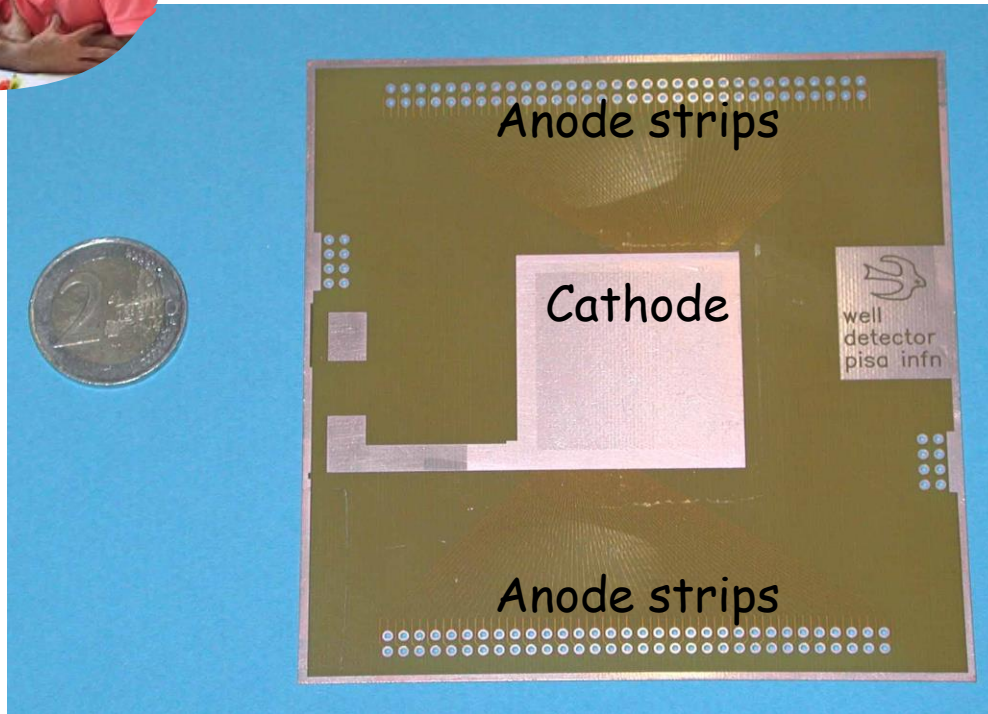
- DLC on APICAL NP 50um for medium rate Micromegas
  - tests nearly finished → detectors in production
  - Up to 600mm x 600mm OK
  - Need some more tests to stabilize 1.7m x 0.6m
- DLC/Cr/Cu on APICAL NP 50um for high rate Micromegas
  - tests nearly finished → perfect adhesion → detectors in production
  - Up to 600mm x 600mm OK
  - Need some more tests to stabilize 1.7m x 0.6m
- DLC on APICAL NP 50um with 5um on one side for high rate uRwells or uRgrooves
  - Still need some time to improve repeatability → pre-drying optimisation
  - Detectors in production soon
- Improved DLC uniformity.
  - Target → +/-10% over 60cm instead of the present +/-30% over 45cm
  - We will start soon; and we have good ideas
    - Mask on the shutter → there is an effect but not fully satisfactory
    - Mask on the target → to be tested



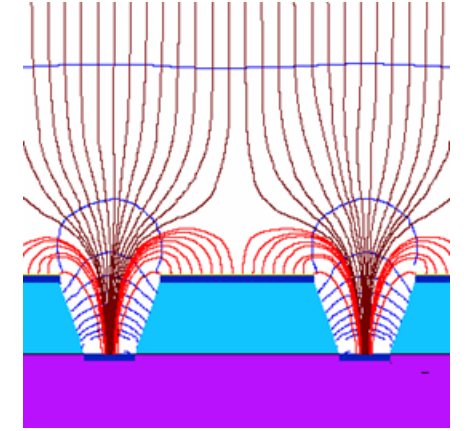
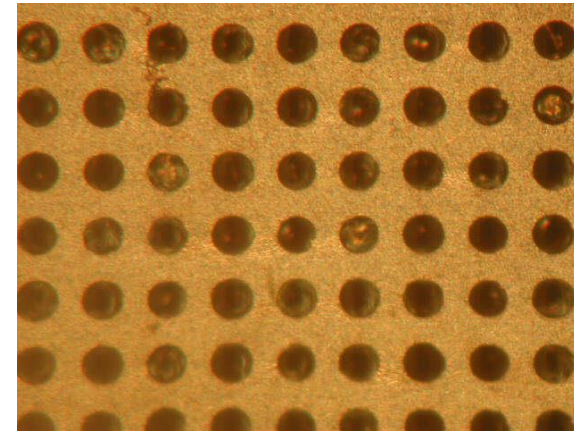
Mask deposition done this week  
by Frascati team  
360ohms/square  
Polyimide mask

uRgrooves

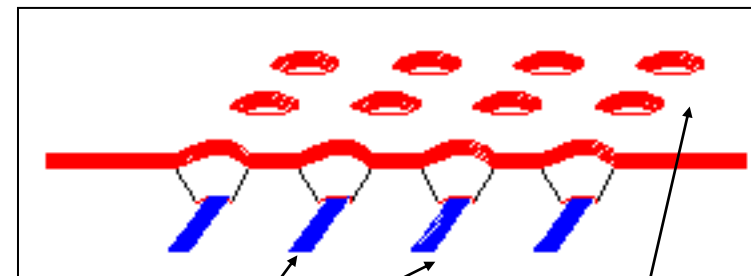
# 1999 → Micro-Well (Ronaldo Bellazzini)



-3 x 3 cm Micro-well detector  
-Produced at MPT with GEM processes  
-Really simple but abandoned due to the difficulty to mitigate sparks



Close-up view  
Square pattern used  
in the early days



R/O lines  
Anode

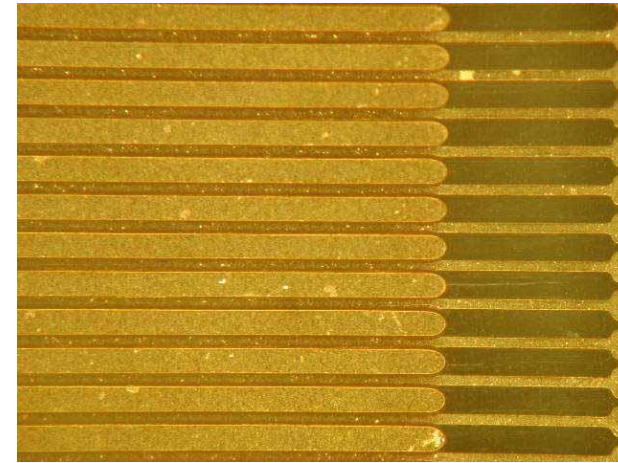
cathode

# A year before → Micro-Groove (Ronaldo Bellazzini)

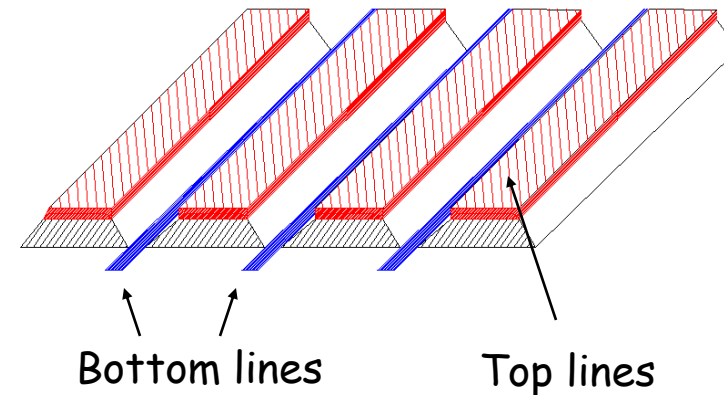
The idea to cross the lines at 90deg was not yet envisaged.  
→ MSGC heritage



12 x 10cm groove detector



Close-up view





# 2015 → Resistive layer introduction (Giovanni Bencivenni)

↓  
uRwell/uRgroove

Polyimide coated foil: copper top, DLC bottom



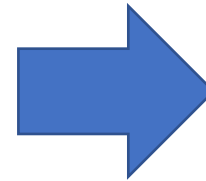
28um Prepreg



PCB with single axis lines



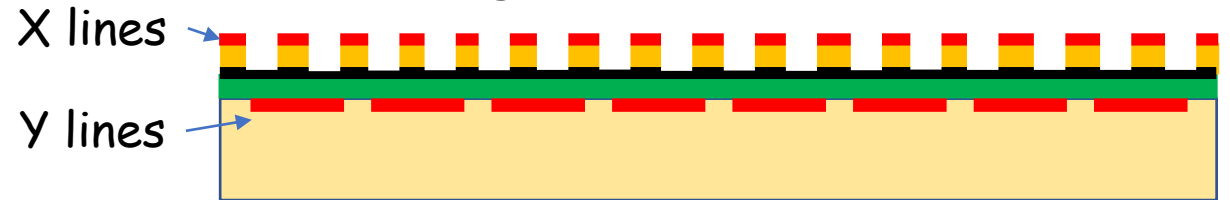
↓  
After vacuum gluing



Make wells (GEM holes) → 1 D detector



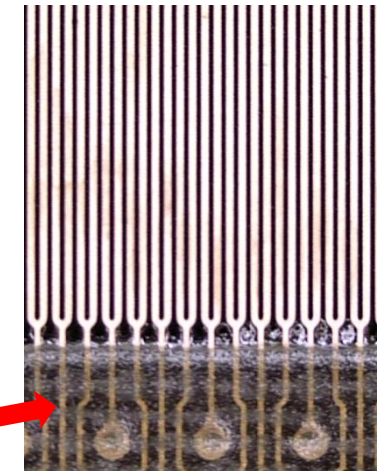
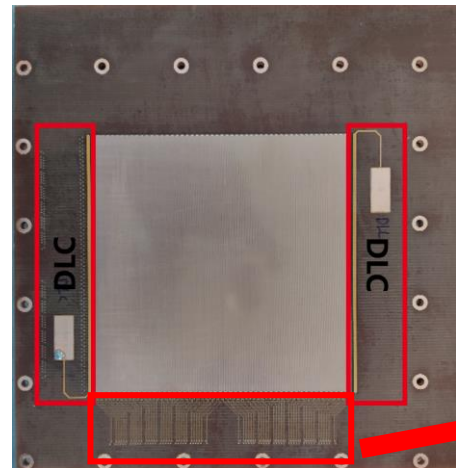
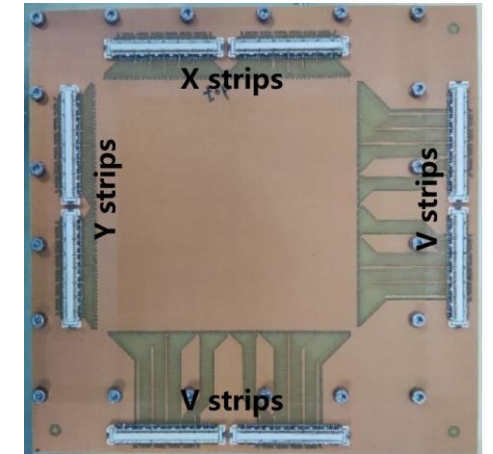
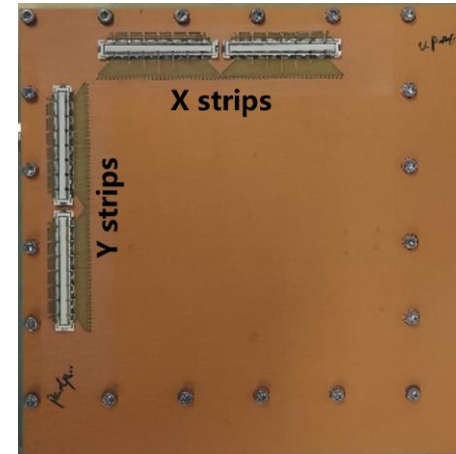
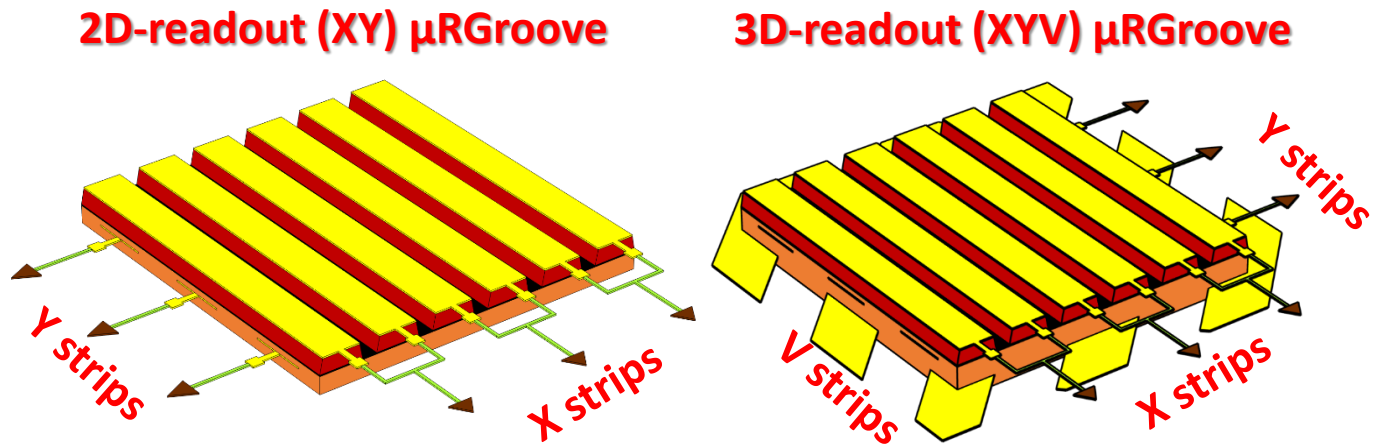
Make grooves → 2D detector



uRgrooves → good space resolution, less production steps, perfect X/Y ratio, less material,  
-Possibility to reduce strips capacity by reducing the width of Y and X strips (TBC).

# Design of 10cm×10cm $\mu$ RGrooves prototypes

(Siqi He's slide , Zhou Yi team) (detector produced @CERN)

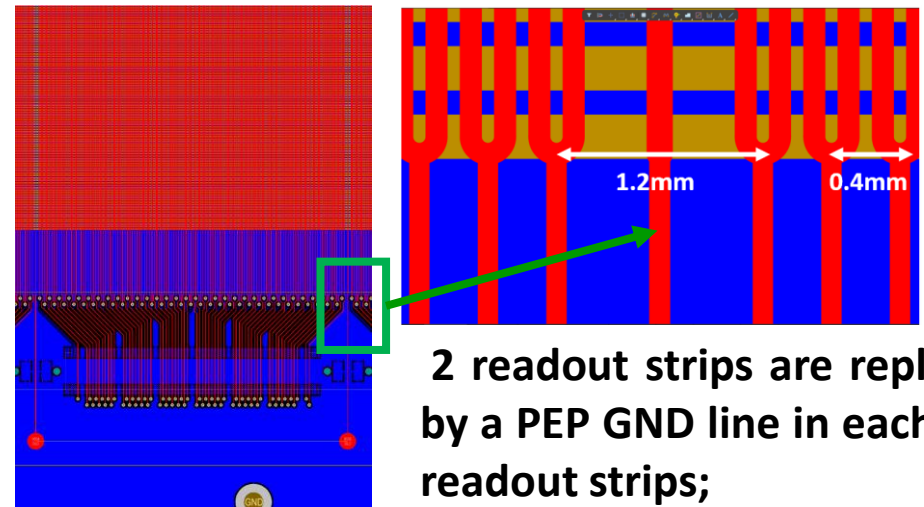
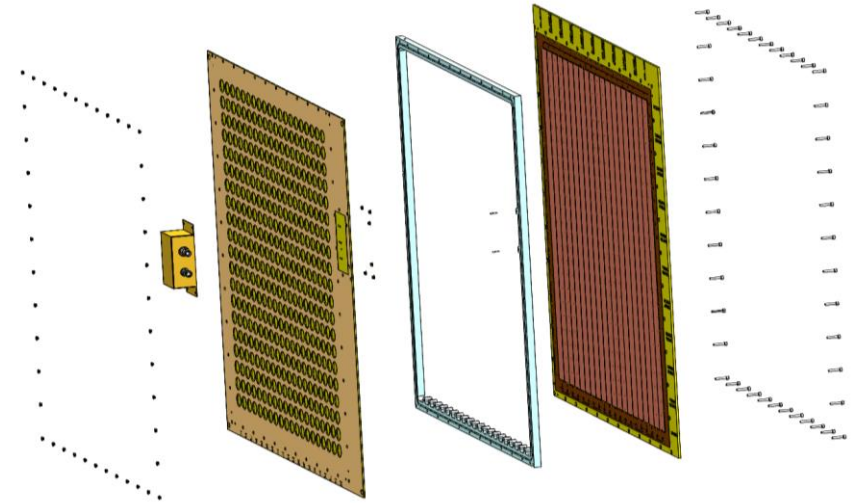
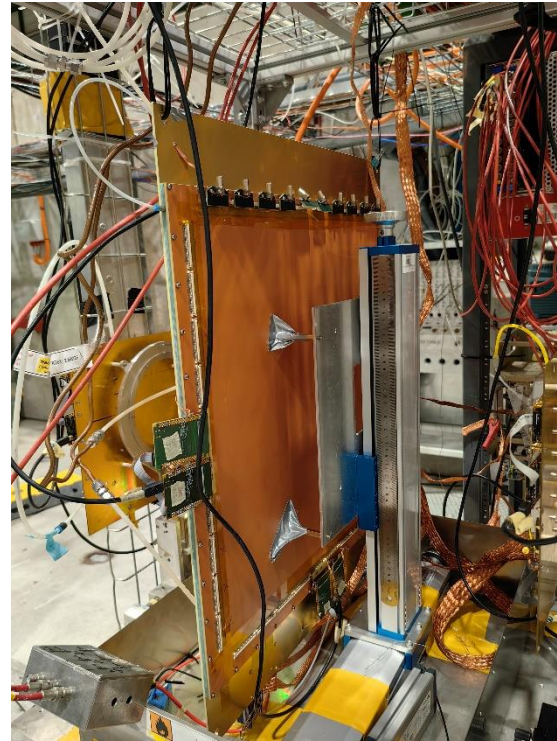
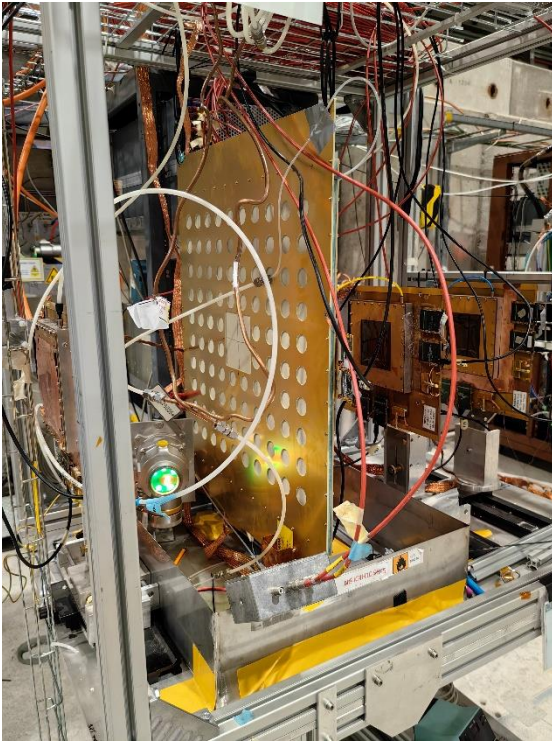


- Two version prototypes of 10cm×10cm
- Groove pitch: 200 $\mu$ m, 2 grooves are connected making 1 strip
- 2D-version, Y and X pitch: 400 $\mu$ m
- 3D-version, X/Y/V pitch: 400 $\mu$ m , V angle: 45°
- Verify  $\mu$ RGroove structure and charge sharing effect.



# 50cm×50cm 2D- $\mu$ RGroove

(Siqi He's slide, Zhou Yi team) (detector produced @CERN)



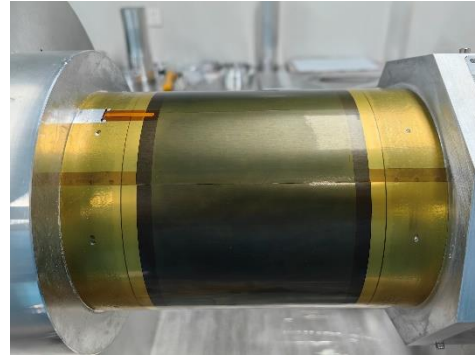
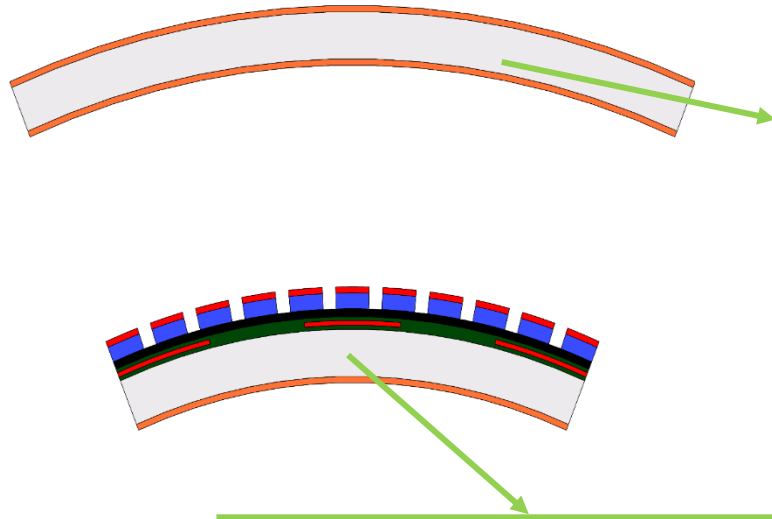
- The central 10cm×10cm area is connected to the electronic system for testing with the rest readout strips grounded
- Same setup of beam test

2 readout strips are replaced by a PEP GND line in each 128 readout strips;

Dead Area (TOP):  $2/128=1.5625\%$

# Cylindrical- $\mu$ RGroove: Manufacture

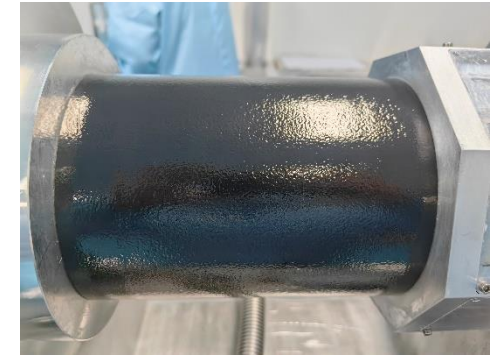
(Siqi He's slide, Zhou Yi team) (detector parts produced @CERN)



Drift electrode



Rohacell foam



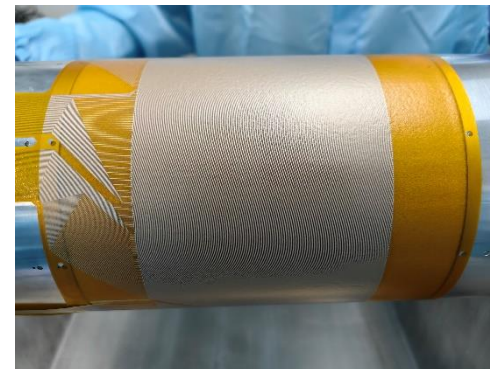
Kapton/GND



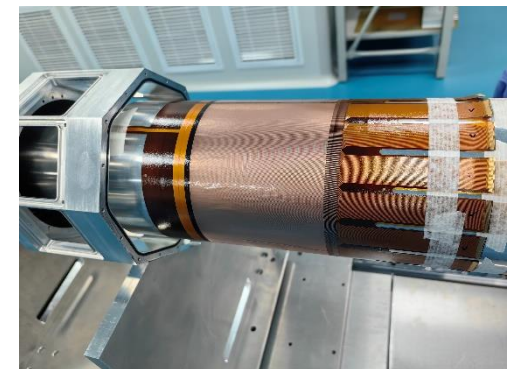
Kapton/GND



Rohacell foam



V strip film



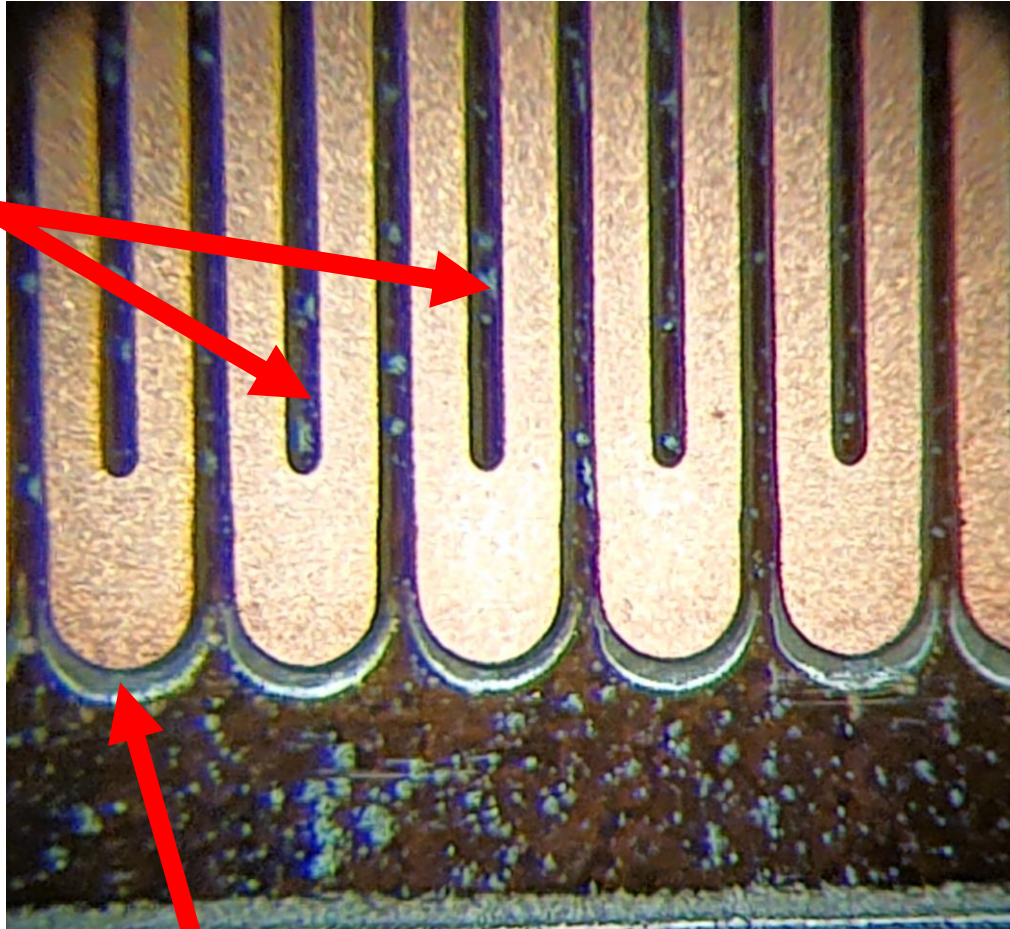
Det.&U-strip film

✓ Total material budget:  $\sim 0.23\%X_0$

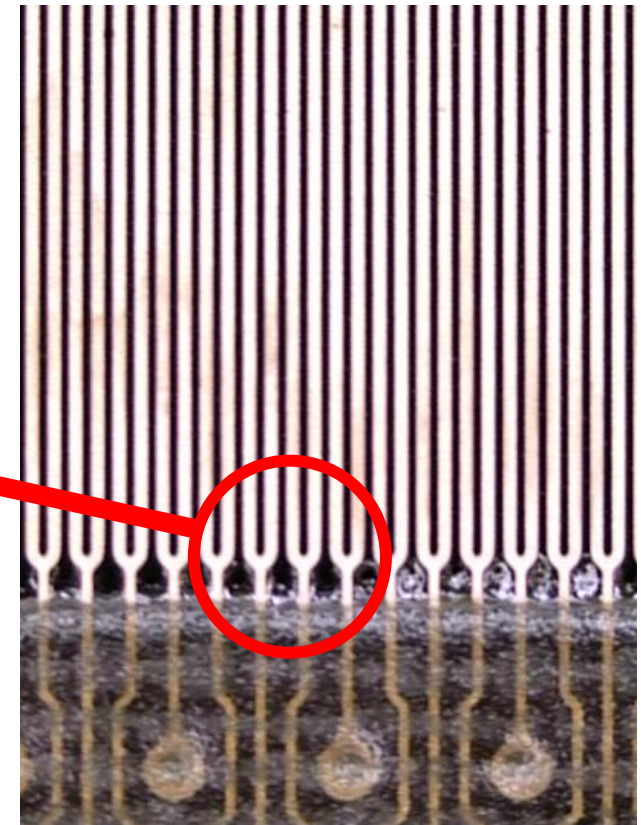
## Electrical cleaning

- Improves the max voltage (typ: from 580V to 670V in hot air@90deg).
- It materializes the places with high parasitic fields.
- It is a powerful tool to optimize the detector design.

After 2mA constant cleaning current at 680V during a full week

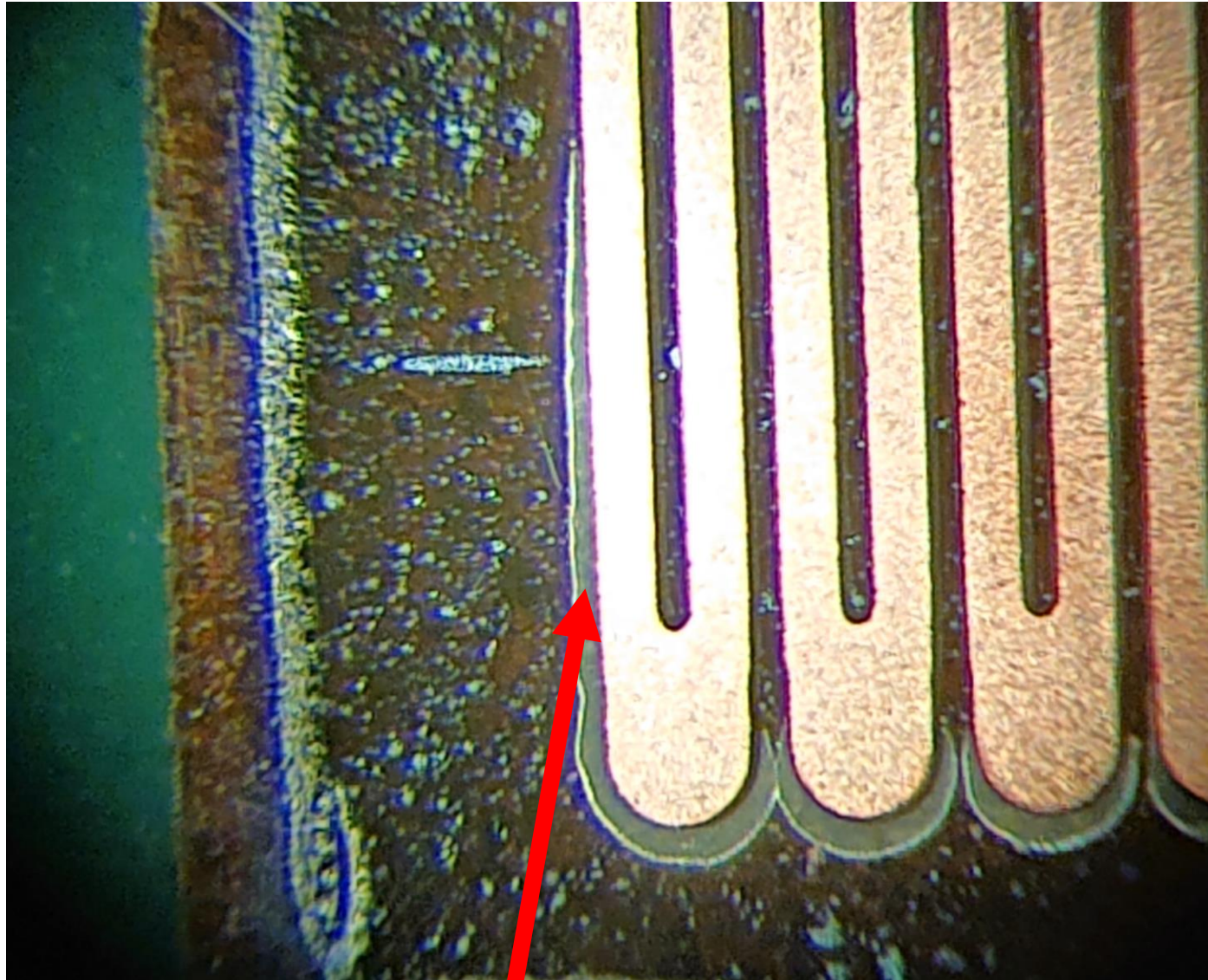


2D uRgroove

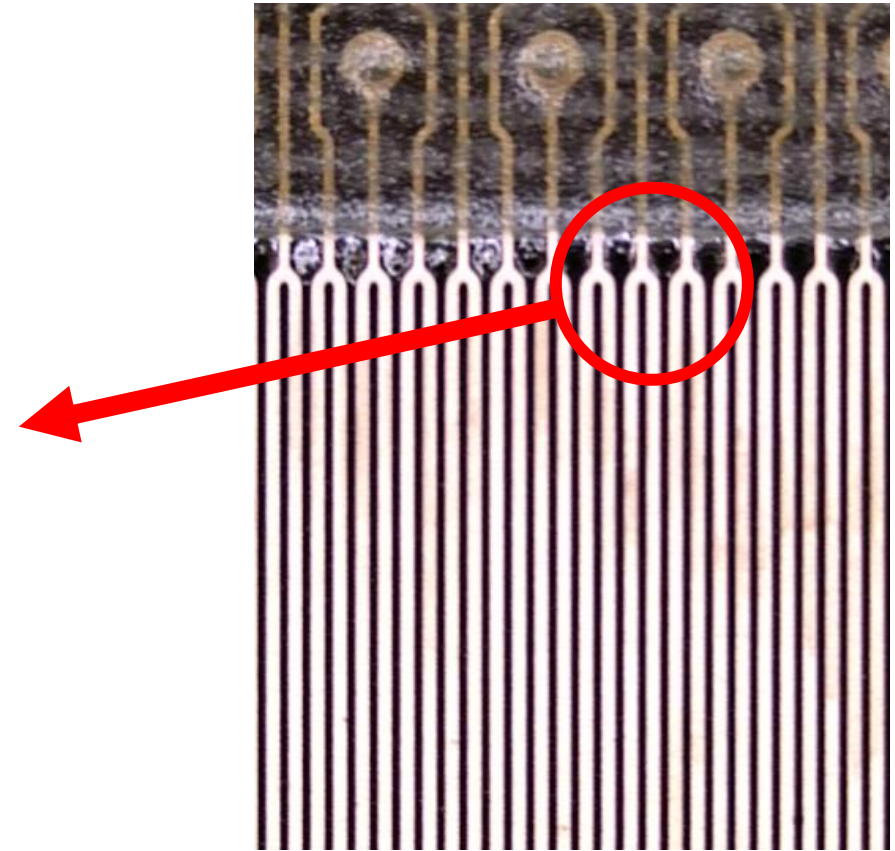
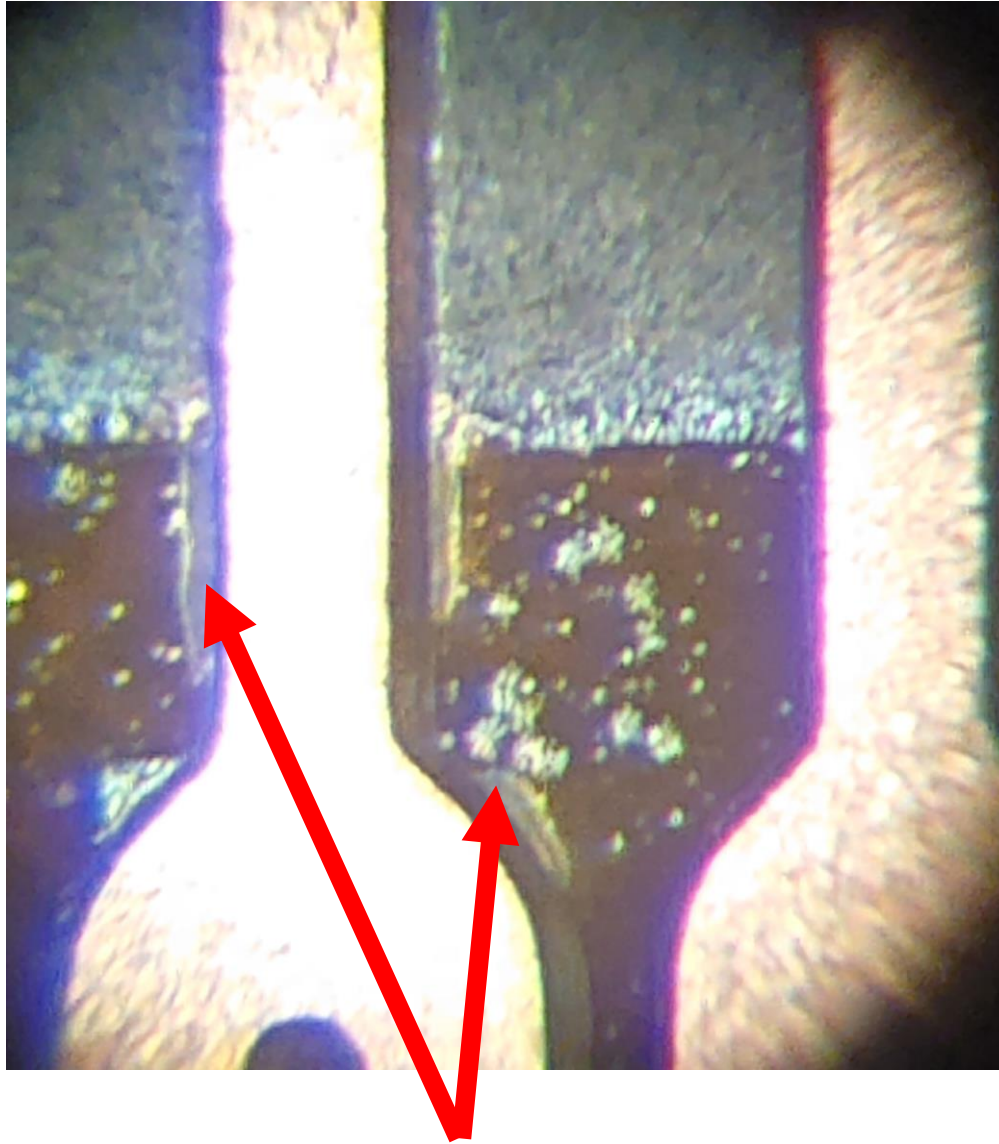


DLC removed by electro cleaning , the fields are clearly higher at this location.

- The detector at the end was operational and the maximum voltage have been recovered.
- Based on this observation we have optimized the layout → we have kept the polyimide hiding the DLC at this location.



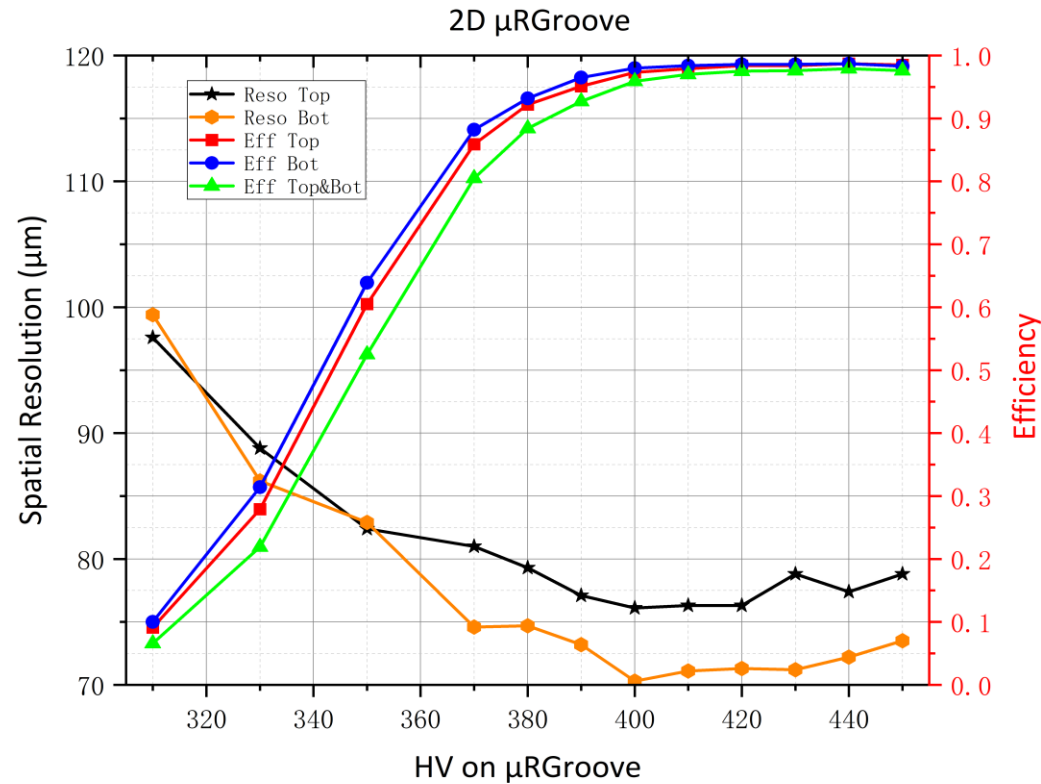
DLC Removed → the field on the last strip is higher → conclusion : we must also keep the Kapton at this location.



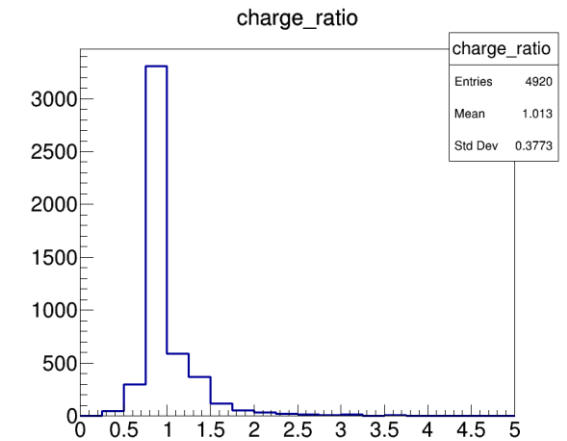
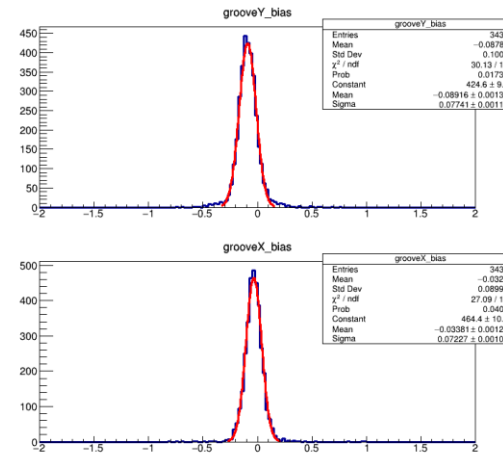
DLC a bit removed → conclusion : in the active area we must keep constant grooves of 70um  
-It would be nice to confirm all these observation with Comsol.

# Beam test: Result of 2D- $\mu$ RGroove (10cm x10cm) improved layout

(Siqi He's slide, Zhou Yi team)



The detector is slightly tilted due to setup issues



➤ Drift electric field is 2kV/cm with 5mm gas gap.

✓ The combined efficiency is about 97.9% and enter plateau at  $\sim$ 410V

✓ Spatial resolution is  $\sim$ 76 $\mu$ m for top readout and 70 $\mu$ m for bot readout

✓ Charge ratio of X/Y is about 1.013

Gas mixture during this test beam : Ar/C<sub>4</sub>H<sub>10</sub> (90/10).  
 Possible other gas mixture: Ar/CO<sub>2</sub>/CF<sub>4</sub> (45/15/40).  
 Also recently tested with same results : Ar/C<sub>4</sub>H<sub>10</sub> (98/2), nonflammable.

# Conclusions

- We have made good progresses with DLC deposition. We are about to finish optimizations.
- Large foils of 1.7m x 0.6m can be produced.
- We know now that we can reach a throughput of 3 to 4 large foils per day.
- uRgroove detectors seems to beat uRwell detectors on many aspects.



